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CLAIMS

- 1. A structure comprising:
- a first conductor;
- a first isolation layer situated over said first conductor;
- a second conductor situated over said first isolation layer, said second conductor comprising under bump metal, said second conductor having at least one external pad;

a second isolation layer situated over said second conductor, said second isolation layer having at least one hole over said at least one external pad of said second conductor;

- a bump attach site located at said at least one hole over said at least one external pad.
- 2. The structure of claim 1 wherein said under bump metal comprises material selected from the group consisting of copper and aluminum.
- 3. The structure of claim 1 wherein said first conductor is between approximately 2.0 microns and 5.0 microns thick.
- 4. The structure of claim 1 wherein said first isolation layer comprises at least one via.
- 5. The structure of claim 4 wherein said first conductor is connected to said second conductor through said at least one via so as to form an inductor.

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- 6. The structure of claim 1 wherein said first conductor comprises interconnect metal.
- 5 7. The structure of claim 6 wherein said interconnect metal comprises material selected from the group consisting of copper and aluminum.
 - 8. The structure of claim 7 wherein said first conductor is between approximately 1.0 micron and approximately 2.0 microns thick.
 - 9. The structure of claim 1 wherein said first conductor is patterned from a layer of under bump metal.
 - 10. The structure of claim 9 wherein said layer of under bump material comprises material selected from the group consisting of copper and aluminum.
 - 11. The structure of claim 10 wherein said first conductor is between approximately 2.0 microns and approximately 5.0 microns thick.
- 20 12. The structure of claim 11 wherein said first and said second isolation layers comprise a dielectric.

- 13. The structure of claim 12 wherein said dielectric comprises a material selected from the group consisting of BCB and polyimide.
- The structure of claim 12 wherein each of said first and said second
 isolation layers is between approximately 5.0 microns and approximately 10.0 microns thick.
 - 15. The structure of claim 1 wherein said second conductor is situated substantially directly above said first conductor.
 - 16. The structure of claim 15 wherein said first and said second conductors are cross-coupled so as to form a transformer.
 - 17. A method for realizing passives, said method comprising steps of: fabricating a first conductor;

forming a first isolation layer over said first conductor;

fabricating a second conductor over said first isolation layer, said second conductor comprising under bump metal, said second conductor having at least one external pad;

forming a second isolation layer over said second conductor, said second isolation layer having at least one hole over said at least one external pad of said second conductor; fabricating a bump attach site at said at least one hole over said at least one

external pad.

- 18. The method of claim 17 wherein said under bump metal comprises material selected from the group consisting of copper and aluminum.
- 19. The method of claim 17 wherein said first conductor is between approximately 2.0 microns and 5.0 microns thick.
- 20. The method of claim 17 further comprising a step of fabricating at least one via in said first isolation layer prior to said step of depositing said second isolation layer.
- 21. The method of claim 20 further comprising a step of connecting said first conductor to said second conductor through said at least one via so as to form an inductor.
- 22. The method of claim 17 wherein said first conductor comprises interconnect metal.
- 23. The method of claim 22 wherein said interconnect metal comprises material
 selected from the group consisting of copper and aluminum.
 - 24. The method of claim 23 wherein said first conductor is between

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approximately 1.0 micron and approximately 2.0 microns thick.

- 25. The method of claim 17 wherein said first conductor is patterned from a layer of under bump metal.
- 26. The method of claim 25 wherein said layer of under bump metal comprises material selected from the group consisting of copper and aluminum.
- 27. The method of claim 26 wherein said first conductor is between approximately 2.0 microns and approximately 5.0 microns thick.
- 28. The method of claim 27 wherein said first and said second isolation layers comprise a dielectric.
- 29. The method of claim 28 wherein said dielectric comprises a material selected from the group consisting of BCB and polyimide.
- 30. The method of claim 17 wherein each of said first and said second isolation layers is between approximately 5.0 microns and approximately 10.0 microns thick.
- 31. The method of claim 17 wherein said second conductor is fabricated substantially directly above said first conductor.

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32. The structure of claim 31 wherein said first and said second conductors are cross-coupled so as to form a transformer.